

Application No. 10/757,204
Inventor: Chi-Ming Ke
"A New Approach to Improve Ellipsometer Modeling..."
Replacement Sheet 1 of 1

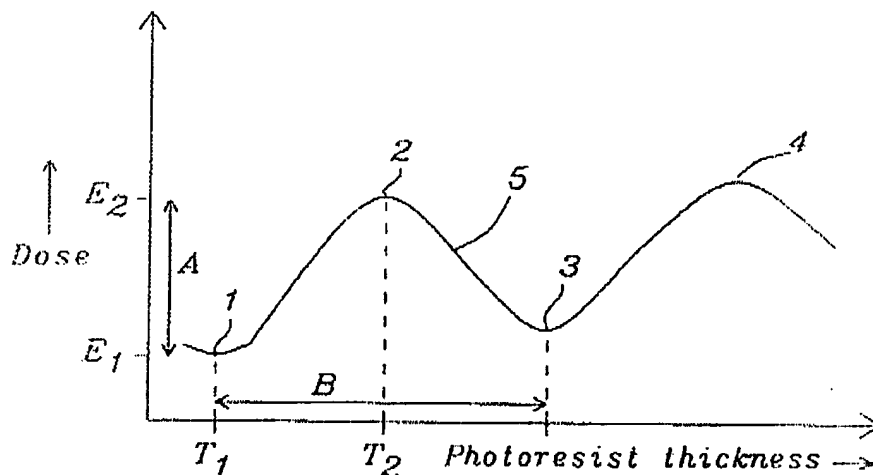
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FIG. 1 - Prior Art

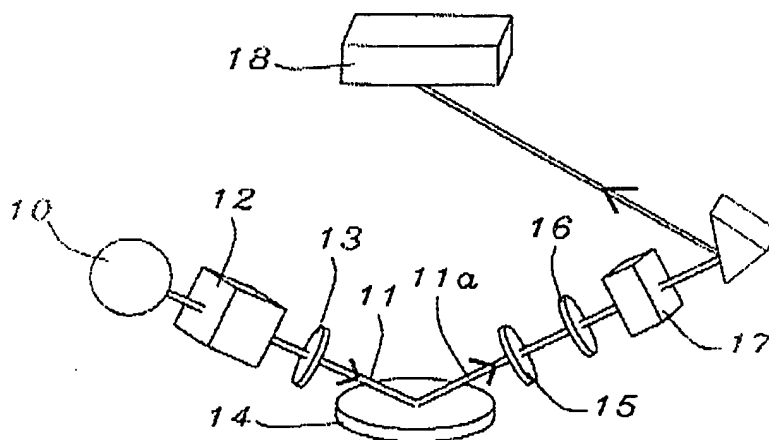


FIG. 2 - Prior Art